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PATENT & TRADEMARK OFFICE

PATENT
Atty. Dkt. AMAT/8657/DISPLAY/AKT/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Choi, et al.

Serial No.: 10/823,347

Filed: April 12, 2004

Confirmation No.: 4736

For: Gas Diffusion Shower Head Design For Large Area Plasma Enhanced Chemical Vapor Deposition

Group Art Unit: 1724

Examiner: Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING
37 CFR 1.8
I hereby certify that this correspondence is being deposited on March 30, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

3/30/05
Date

Signature

Dear Sir:

PRELIMINARY AMENDMENT

Prior to examination, please amend the above-identified application as follows. **Amendments to the Specification** begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 11 of this paper. **Amendments to the Drawings** begin on page 23 of this paper and include both an attached replacement sheet and an annotated sheet showing changes. **Remarks** begin on page 24 of this paper.